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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/627,228	07/25/2003	Farhad K. Moghadam	A7632/T49100	2446
	7590 03/25/200 AND TOWNSEND AN	EXAMINER		
TWO EMBARCADERO CENTER EIGHTH FLOOR SAN FRANCISCO, CA 94111-3834			MCDONALD, RODNEY GLENN	
			ART UNIT	PAPER NUMBER
			1795	
			MAIL DATE	DELIVERY MODE
			03/25/2008	PAPER

## Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

# Supplemental Notice of Allowability

Application No.	Applicant(s)	_
10/627,228	MOGHADAM ET AL.	
Examiner	Art Unit	
Rodnev G. McDonald	1795	

I NOC	diley G. McDollaid
The MAILING DATE of this communication appears of All claims being allowable, PROSECUTION ON THE MERITS IS (OR herewith (or previously mailed), a Notice of Allowance (PTOL-85) or of NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHT of the Office or upon petition by the applicant. See 37 CFR 1.313 and	REMAINS) CLOSED in this application. If not included ther appropriate communication will be mailed in due course. <b>THIS</b> 'S. This application is subject to withdrawal from issue at the initiative
1. $\boxtimes$ This communication is responsive to <u>After Final Amendment file</u>	ed 10-16-07.
2. The allowed claim(s) is/are <u>1-28</u> .	
<ul> <li>3. Acknowledgment is made of a claim for foreign priority under 3</li> <li>a) All b) Some* c) None of the:</li> <li>1. Certified copies of the priority documents have bee</li> <li>2. Certified copies of the priority documents have bee</li> </ul>	n received.
	ents have been received in this national stage application from the
International Bureau (PCT Rule 17.2(a)).	
* Certified copies not received:	
Applicant has THREE MONTHS FROM THE "MAILING DATE" of thi noted below. Failure to timely comply will result in ABANDONMENT THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	
4. A SUBSTITUTE OATH OR DECLARATION must be submitted. INFORMAL PATENT APPLICATION (PTO-152) which gives real	
<ol> <li>CORRECTED DRAWINGS (as "replacement sheets") must be</li> <li>(a) including changes required by the Notice of Draftsperson's</li> <li>1) hereto or 2) to Paper No./Mail Date</li> <li>(b) including changes required by the attached Examiner's Am Paper No./Mail Date</li> </ol>	Patent Drawing Review ( PTO-948) attached
Identifying indicia such as the application number (see 37 CFR 1.84(c) each sheet. Replacement sheet(s) should be labeled as such in the he	
<ol> <li>DEPOSIT OF and/or INFORMATION about the deposit of attached Examiner's comment regarding REQUIREMENT FOR</li> </ol>	
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. Notice of Informal Patent Application
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary (PTO-413),
3. Information Disclosure Statements (PTO/SB/08),	Paper No./Mail Date  7. Examiner's Amendment/Comment
Paper No./Mail Date  4.  Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. X Examiner's Statement of Reasons for Allowance
	9.  Other
	/Rodney G. McDonald/
	Primary Examiner, Art Unit 1795

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#### **REASONS FOR ALLOWANCE**

### Oath/Declaration

The oath or declaration is defective. A new oath or declaration in compliance with 37 CFR 1.67(a) identifying this application by application number and filing date is required. See MPEP §§ 602.01 and 602.02.

The oath or declaration is defective because:

It does not identify the mailing address of each inventor. A mailing address is an address at which an inventor customarily receives his or her mail and may be either a home or business address. The mailing address should include the ZIP Code designation. The mailing address may be provided in an application data sheet or a supplemental oath or declaration. See 37 CFR 1.63(c) and 37 CFR 1.76.

It does not identify the city and either state or foreign country of residence of each inventor. The residence information may be provided on either an application data sheet or supplemental oath or declaration.

#### Reasons for Allowance

The following is an examiner's statement of reasons for allowance:

Claims 1, 3-14, 16, 17 and 27 are allowable over the prior art of record because the prior art of record does not teach the claimed subject matter including converting the silicon- containing reactant into a silica glass insulating compound using primarily thermal energy to provide activation energy to drive the deposition reaction by exposing the substrate to oxygen radicals formed from a second reactant while biasing the substrate to promote a sputtering effect.

Claims 2, 19-22 and 28 are allowable over the prior art of record because the prior art of record does not teach the claimed subject matter including converting the silicon-containing reactant into a silica glass insulating compound by exposing the

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substrate to oxygen radicals formed from a second reactant while introducing a fluent gas into the chamber and biasing the substrate to promote a sputtering effect, wherein an average atomic mass of all atomic constituents introduced into the chamber during the converting step is less than or equal to an average atomic mass of oxygen

Claims 15-28 are allowable over the prior art of record because the prior art of record does not teach the claimed subject matter including converting the siliconcontaining reactant into a silica glass insulating compound by exposing the substrate to a plasma formed from a second reactant comprising oxygen atoms while biasing the substrate to promote a sputtering effect, wherein an average atomic mass of all atomic constituents introduced into the chamber during the converting step is less than or equal to an average atomic mass of oxygen and wherein the substrate is maintained at a temperature between 300-800°C during growth of the silica glass film and wherein the silica glass film grows up from the bottom surface of the gap at a rate greater than it grows inward on the sidewall surface of the gap.

The closest prior art of record to Chiang et al. (U.S. Pat. 6,428,859) fails to suggest utilizing thermal energy to drive the reaction but instead uses kinetic energy. Furthermore, the combination of Chiang et al. (U.S. Pat. 6,428,859) with Sherman (U.S. Pat. 6,342,277) results in an oxygen source and one of the ion feed gases described in Chiang during the converting step having an average atomic mass greater than oxygen. The combination of Sherman and Chiang et al. does not result in the invention of claims 2 and 15 which requires that the average atomic mass of all constituents introduced

into the chamber during the converting step be less than or equal to the average atomic mass of oxygen.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Rodney G. McDonald whose telephone number is 571-272-1340. The examiner can normally be reached on M-Th with every Friday off..

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam X. Nguyen can be reached on 571-272-1342. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <a href="http://pair-direct.uspto.gov">http://pair-direct.uspto.gov</a>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Rodney G. McDonald/ Primary Examiner, Art Unit 1795

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